

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

CE #16D

Amelt

Allufur

2-1313

APPLICANT:

Rabarot, et al.

**SERIAL NO.:** 

09/601,382

FILING DATE:

September 21, 2000

TITLE:

METHOD FOR MAKING MICRORELIEFS, AND ESPECIALLY

MICROPRISMS BY MICRO-MACHINING AND TOOLS FOR

IMPLEMENTING THE METHOD

**EXAMINER:** 

S. Blount

**ART UNIT:** 

3726

**CERTIFICATE OF MAILING** 

I hereby certify that this paper is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231, on the date printed below:

Date: /-23-03

**BOX FEE COMMISSIONER FOR PATENTS** WASHINGTON, D.C. 20231

## RESPONSE TO OFFICE ACTION AND AMENDMENT

In response to the Office Action dated August 23, 2002, please review the remarks regarding the above-mentioned application as follows. It is believed that a two-month extension is needed, and Applicant hereby requests an appropriate extension.

01/30/2003 AWONDAF1 00000155 09601382

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